



IPW

Docket No. 249353US3
IN RE APPLICATION OF: Masaaki TAKATA, et al.
SERIAL NO: 10/786,555
FILED: February 26, 2004
FOR: OUTER TUBE MADE OF SILICON CARBIDE AND THERMAL TREATMENT SYSTEM FOR SEMICONDUCTORS

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:
Transmitted herewith is an amendment in the above-identified application.

- ☒ No additional fee is required
☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	7	MINUS	20	0	x \$50 =	\$0.00
INDEPENDENT	2	MINUS	3	0	x \$200 =	\$0.00
APPLICATION SIZE	33	MINUS	100	0 (each addtl. 50 sheets over 100)	x \$250 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$360 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
		TOTAL				\$0.00

- ☐ A check in the amount of \$0.00 is attached.
☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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DOCKET NO: 249353US3

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IMPRE APPLICATION OF :

MASAAKI TAKATA, ET AL.

: EXAMINER: LUND, JEFFRIE ROBERT

SERIAL NO: 10/786,555 :

FILED: FEBRUARY 26, 2004

: GROUP ART UNIT: 1763

FOR: OUTER TUBE MADE OF SILICON :
CARBIDE AND THERMAL TREATMENT
SYSTEM FOR SEMICONDUCTORS

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated October 12, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

